



PATENT APPLICATION

IN THE U.S. PATENT AND TRADEMARK OFFICE

September 2, 2009

Applicants: Takaomi NAKAYAMA et al  
For: TREATING SOLUTION FOR SURFACE TREATMENT OF METAL AND  
A METHOD FOR SURFACE TREATMENT

Serial No.: 10/537 329                      Group: 1793  
Confirmation No.: 8404  
Filed: December 2, 2005                      Examiner: Zheng  
International Application No.: PCT/JP2003/015868  
International Filing Date: December 11, 2003  
Atty. Docket No.: 4626.P0002US

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

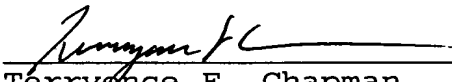
RESPONSE

Sir:  
In response to the Office Action dated June 4, 2009,  
please amend the above-identified application as follows:  
(Please see following pages.)

-----

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being  
deposited with the United States Postal Service with  
sufficient postage as first class mail in an envelope  
addressed to: Commissioner for Patents, P.O. Box 1450,  
Alexandria, VA 22313-1450, on September 2, 2009.

  
Terryence F. Chapman